



Monolithic Mid-Infrared Photonic Integration of a Quantum Cascade Laser and a Passive Semiconductor Waveguide

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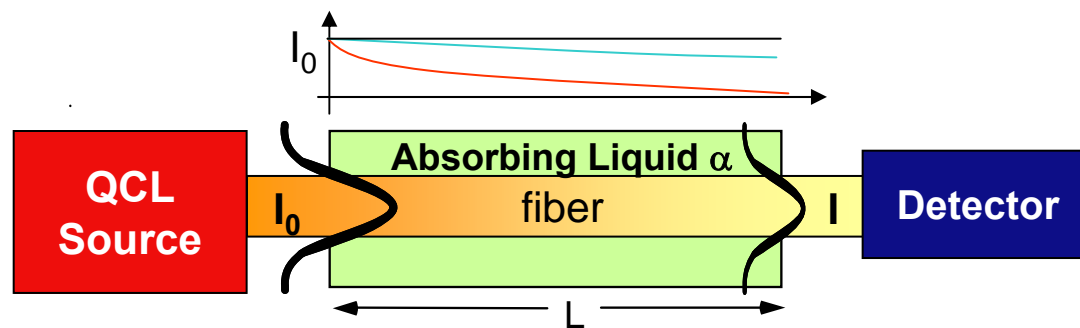
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Motivation

Liquid Sensing

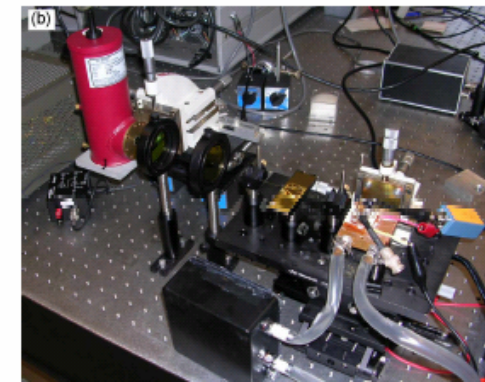
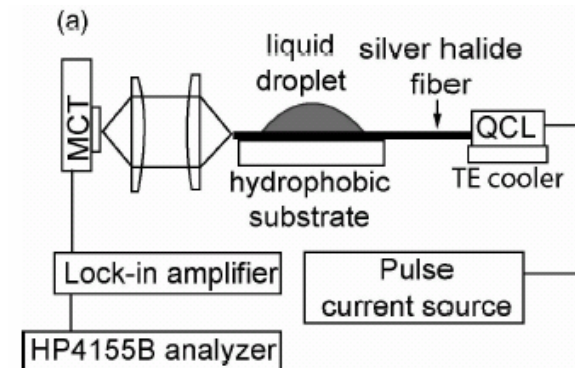


J.Z. Chen *et al.*, “Silver halide fiber-based evanescent-wave liquid droplet sensing...” *Optics Express* **13**, 5953 (2005).



$$\frac{I}{I_0} = e^{-\alpha L}$$

**2 vol%
Acetone in H₂O**



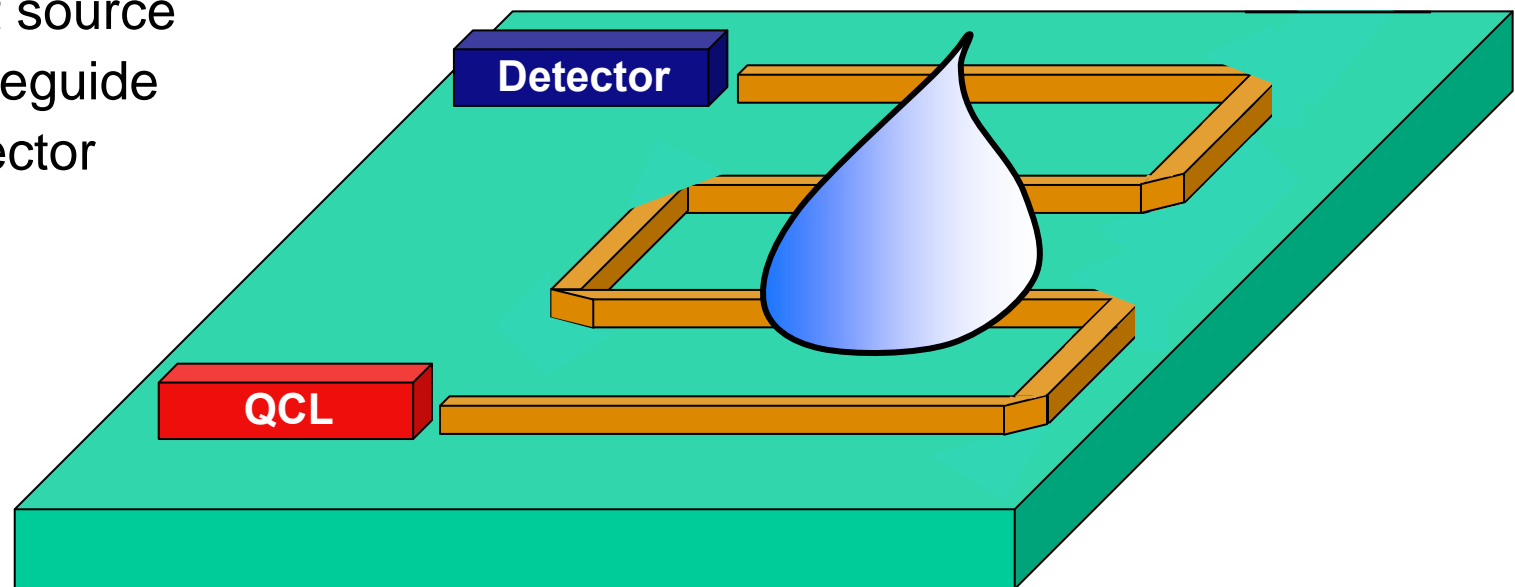
C. Charlton, A. Katzir, B. Mizaikoff, “Infrared Evanescent Field Sensing with Quantum Cascade Lasers and Planar Silver Halide Waveguides” *Anal. Chem.* **77**, 4398 (2005).

Motivation

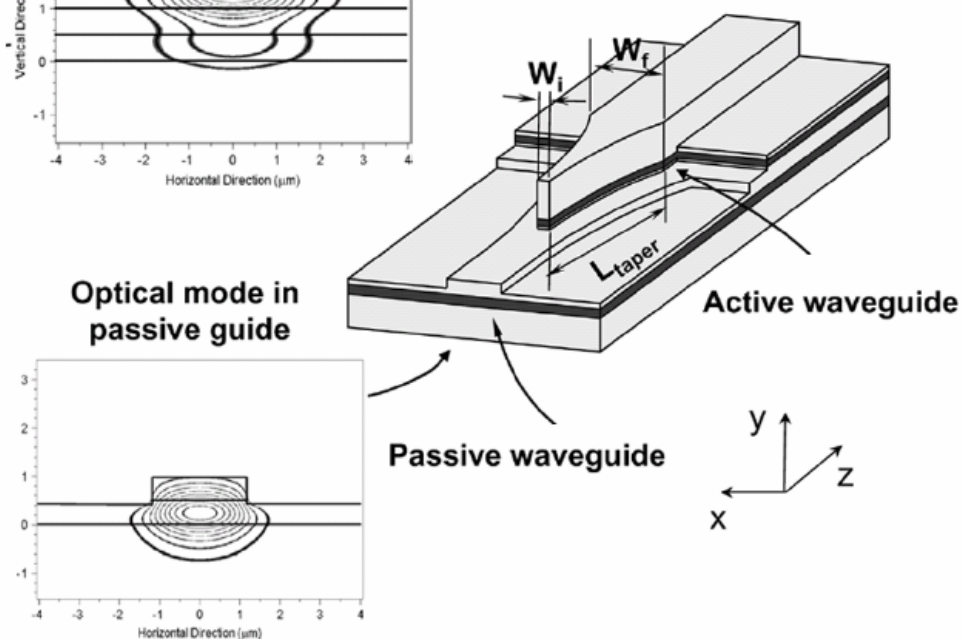
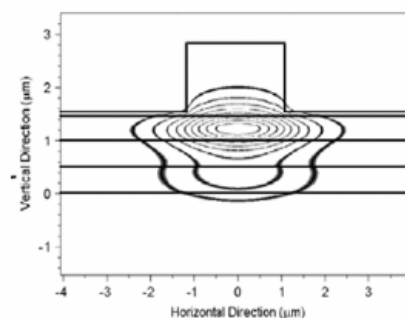
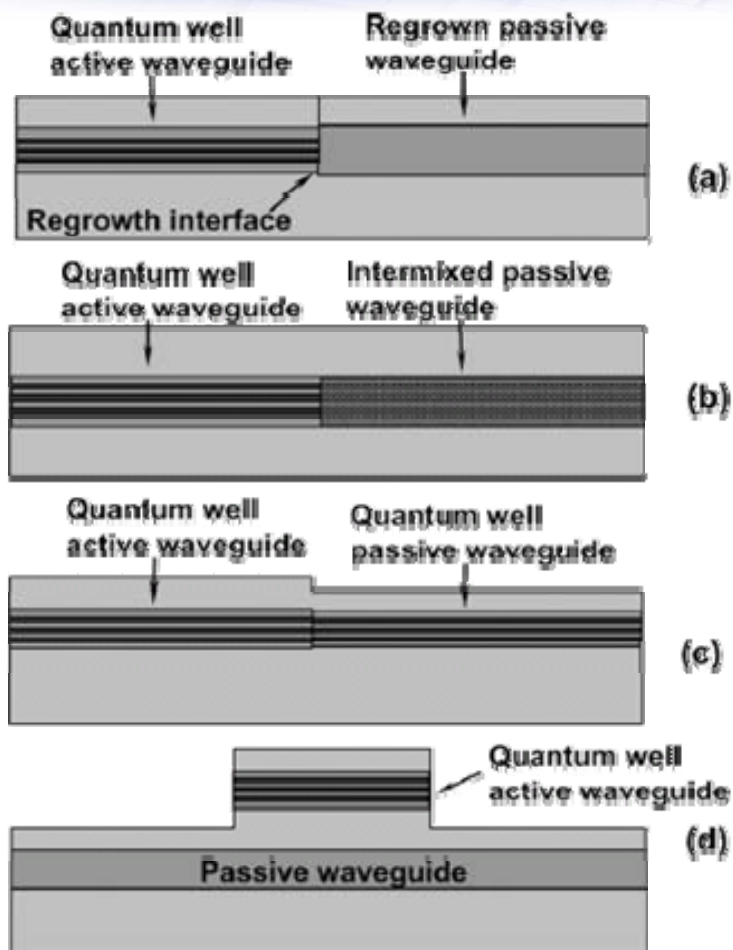
Mid-IR Integration



- Our goals in this work
 - + Create on-chip mid-IR integration scheme
 - + Increase sensitivity for liquid-phase detection
- Three key components
 - + light source
 - + waveguide
 - + detector



Integration Methods

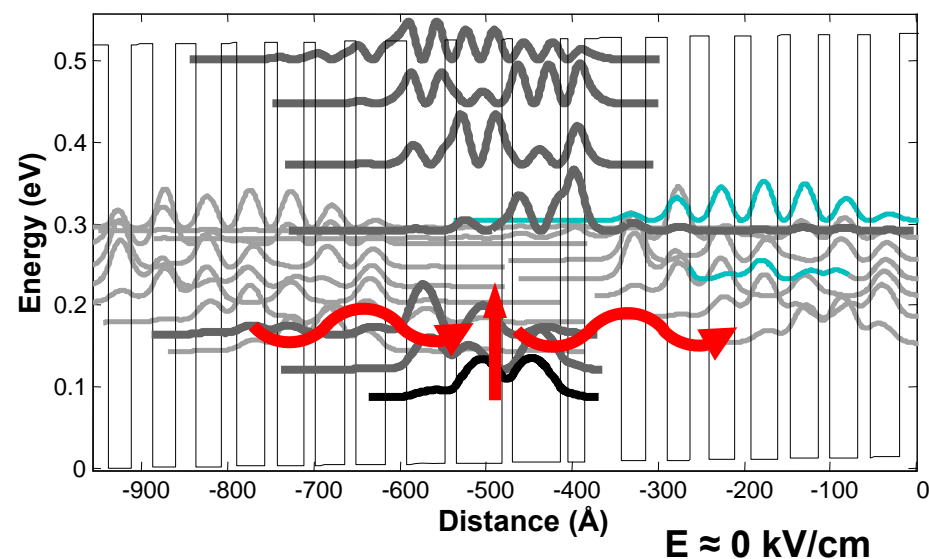
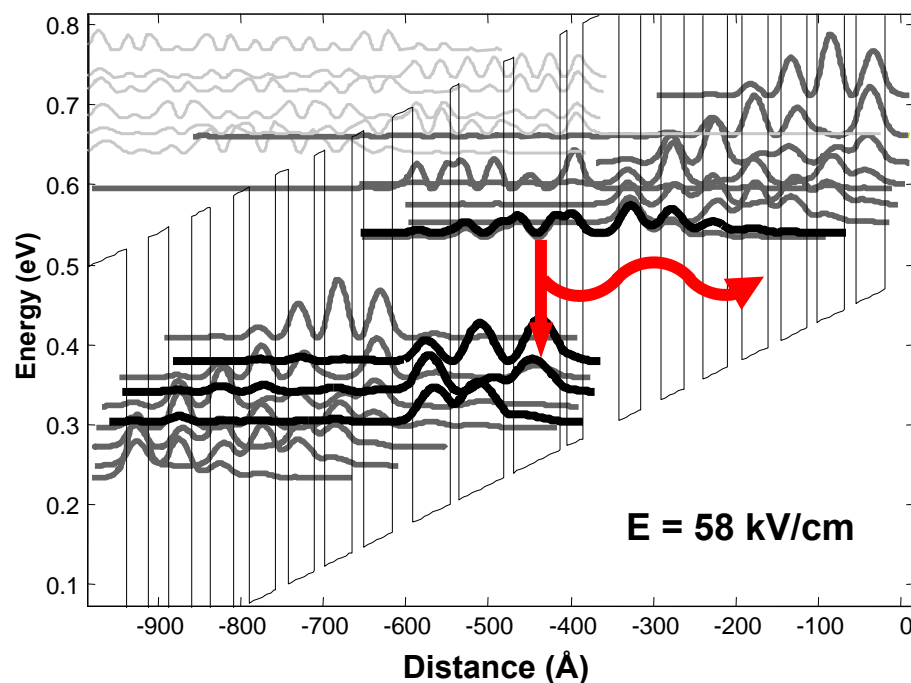


F. Xia, V.M. Menon, and S.R. Forrest, "Photonic Integration Using Asymmetric Twin-Waveguide (ATG) Technology: Part I—Concepts and Theory," *J. Selected Topics in Quant. Elec.* **11**, 17-29 (2005).

Integration Methods



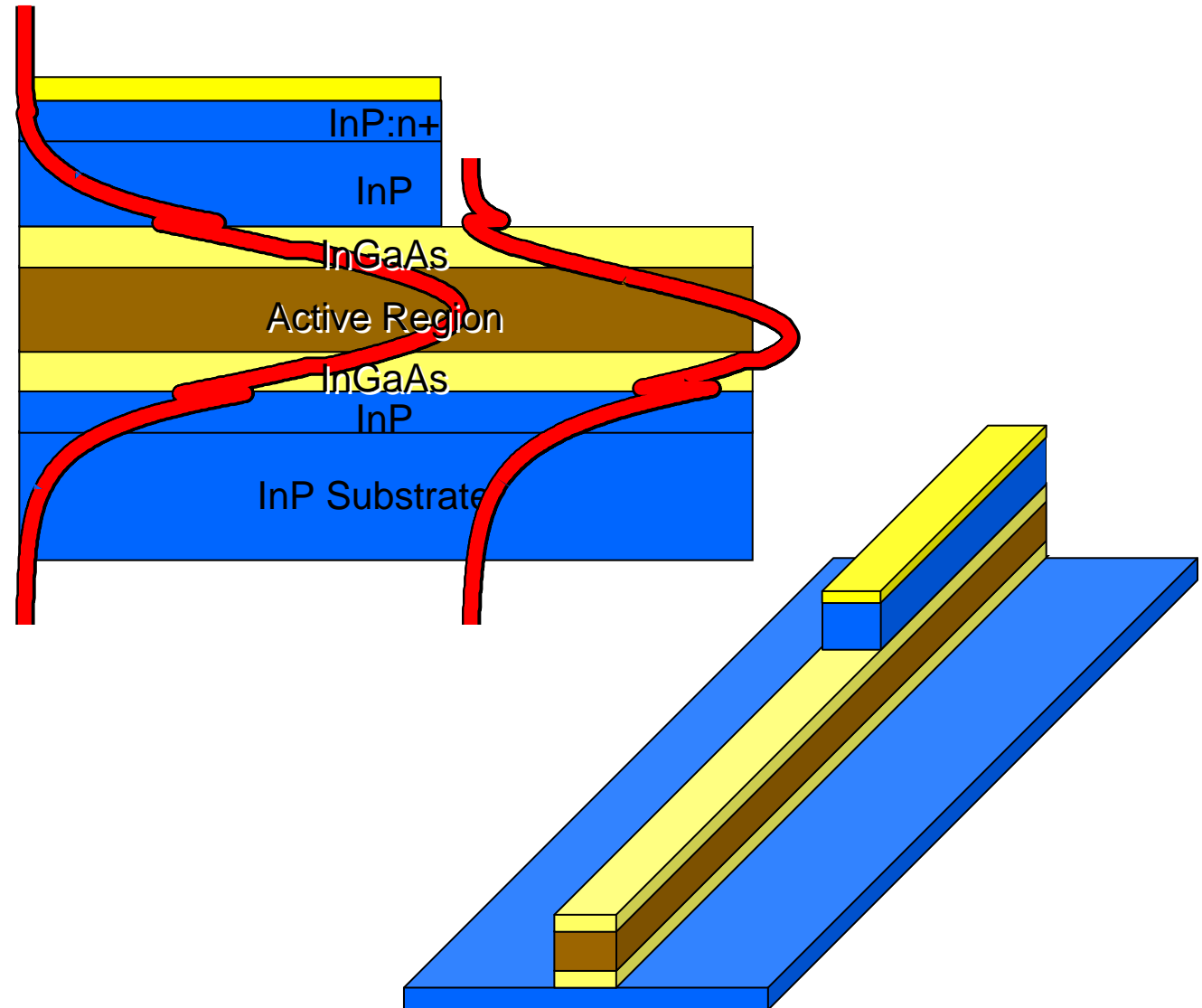
QC laser structures as waveguides



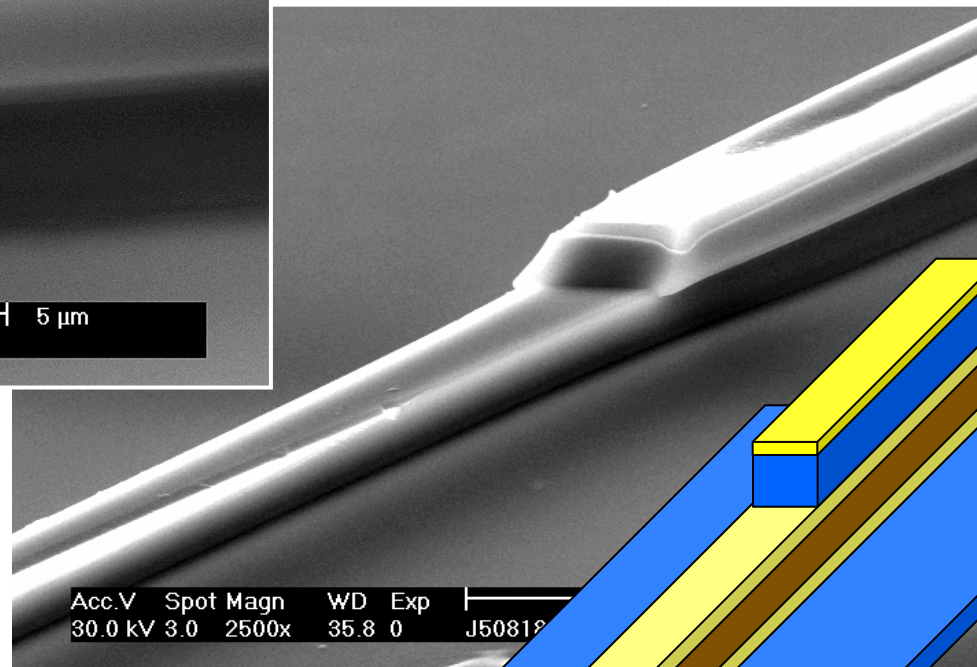
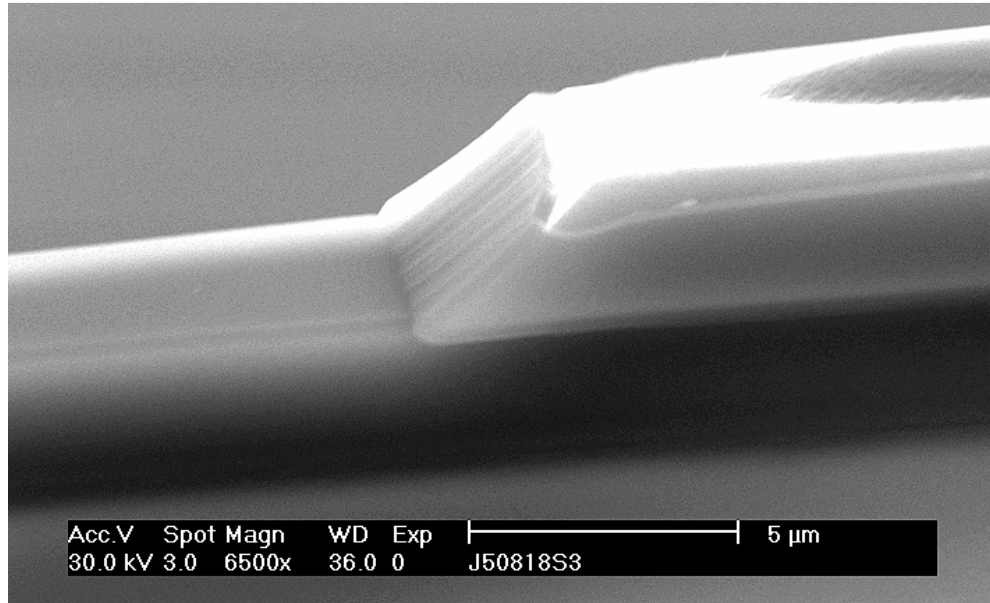
Fabrication



1. Start with epitaxial growth
2. Use photoresist to block half of wafer
3. Use HCl selective etch to remove top InP
4. Continue making laser ridge as before



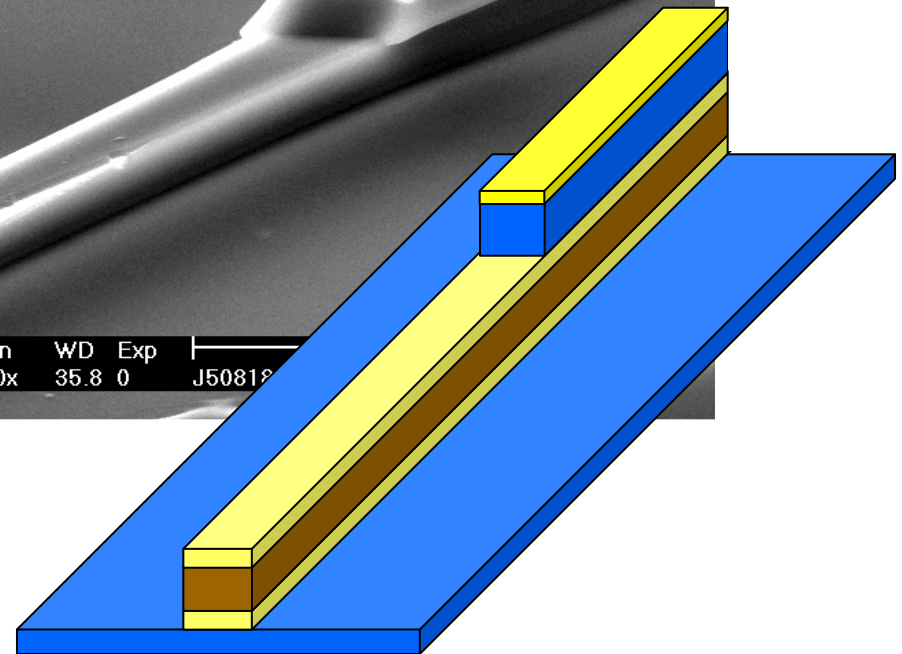
Fabrication



HBr:HNO₃ wet etch

3 mm laser

8 mm total length



Reflection at the Laser-Waveguide Interface

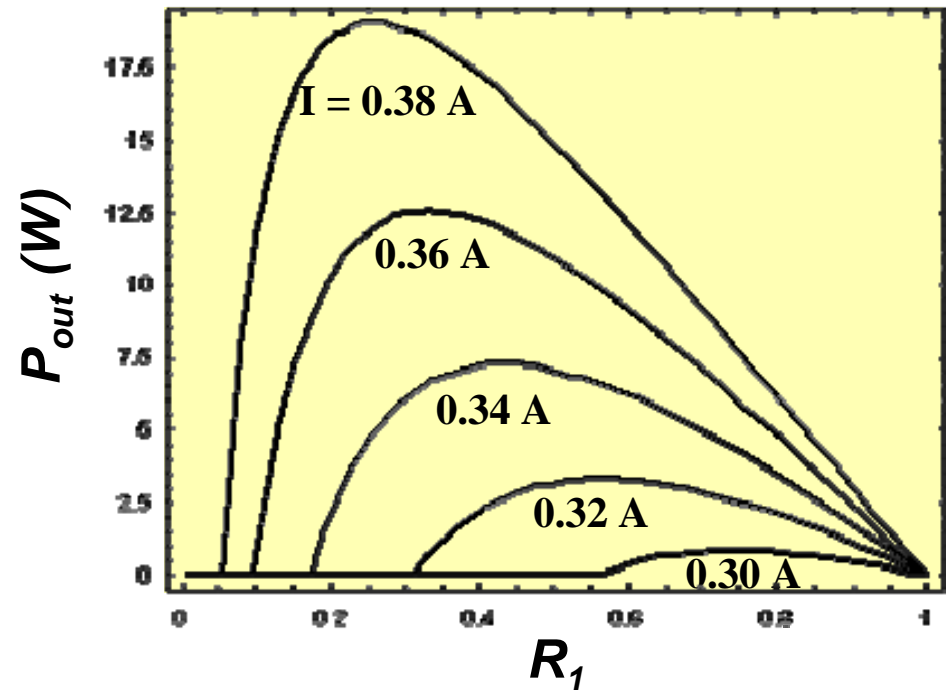


$$P_{out} = \eta_{ext} (I - I_{th})$$

$$\eta_{ext} = \frac{1}{2} \frac{\epsilon_{32}}{q} N_p \left(1 - \frac{\tau_2}{\tau_{32}} \right) \frac{\frac{1}{2L} \ln \frac{1}{R_1}}{\alpha_m + \alpha_w}$$

$$I_{th} = \frac{\alpha_m + \alpha_w}{g\Gamma} A$$

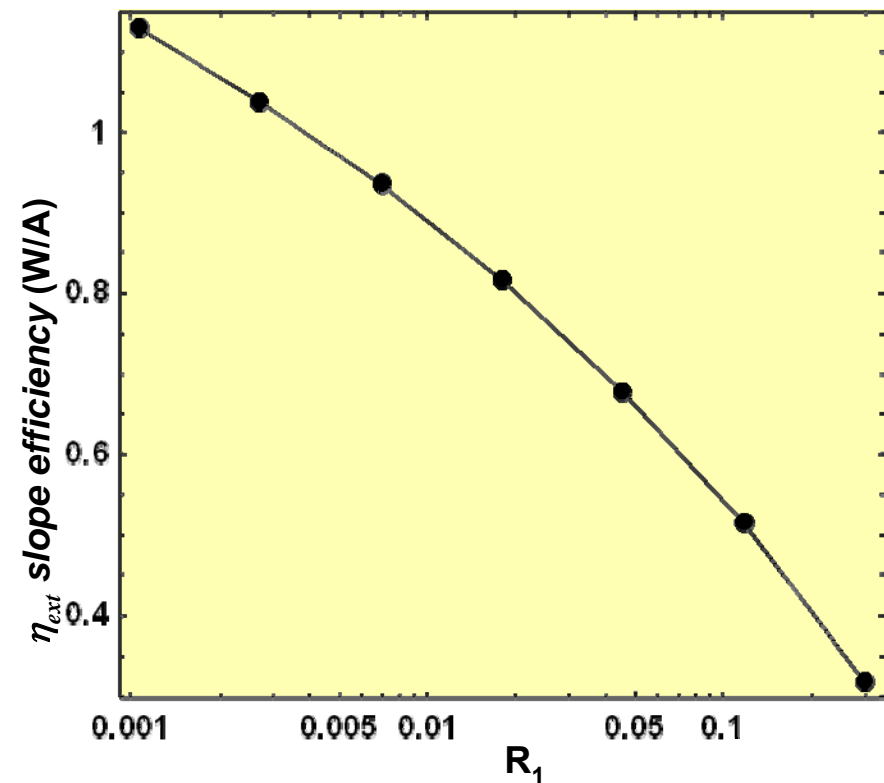
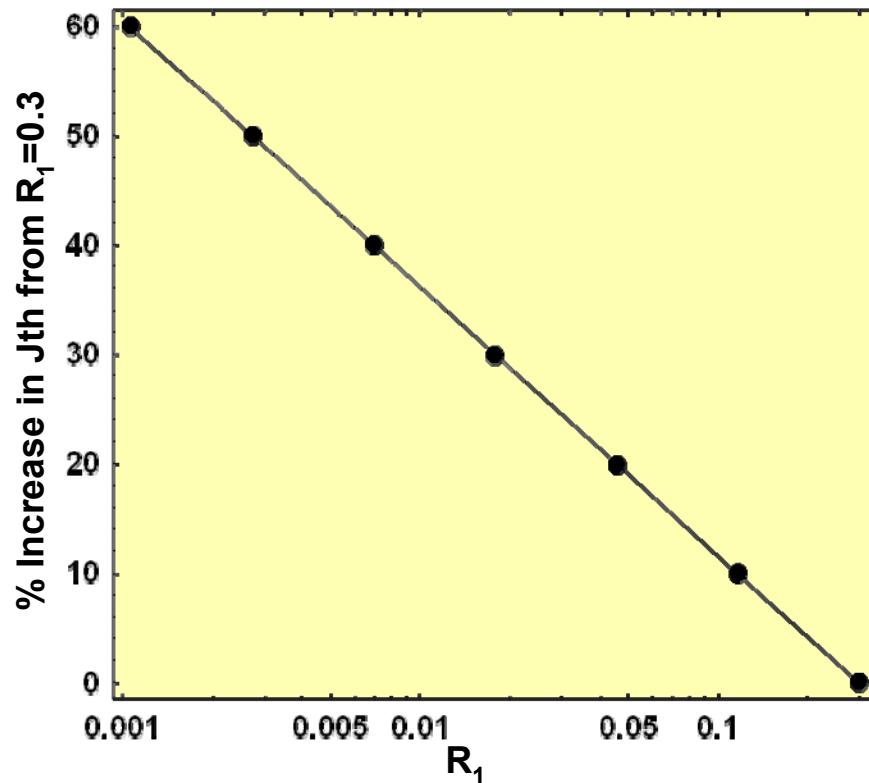
$$\alpha_m = \frac{1}{2L} \ln \left(\frac{1}{R_1 R_2} \right)$$



$L = 0.25 \text{ cm}$	$\Gamma = 0.55$	$g = 0.04 \text{ cm/A}$
$A = 3.8 \times 10^{-4} \text{ cm}^2$	$E_{32} = 155 \text{ meV}$	$N_p = 40$
$\tau_2 = 0.3 \text{ ps}$	$\tau_{32} = 1.5 \text{ ps}$	$\alpha_w = 14 \text{ cm}^{-1}$
	$R_2 = 0.3$	

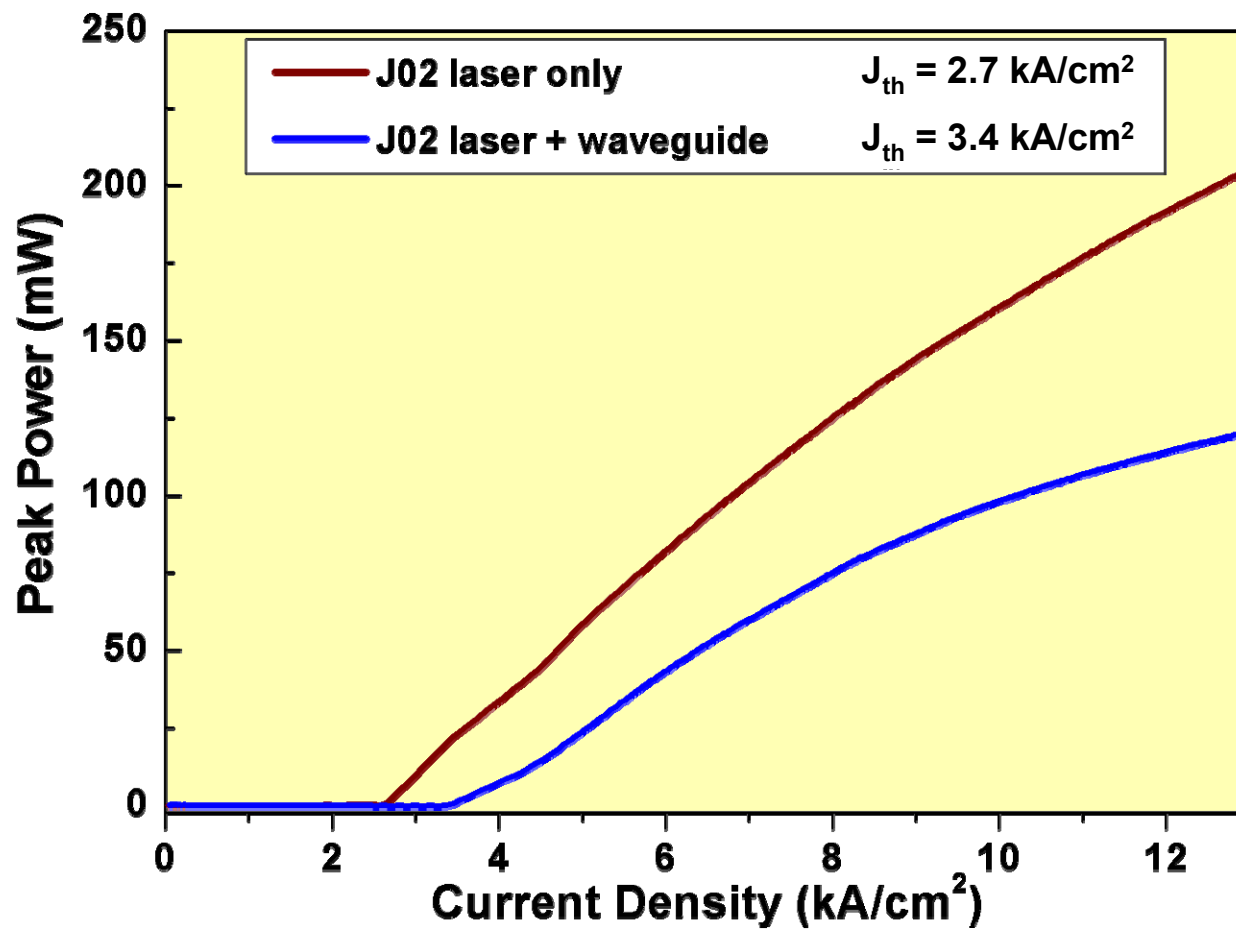
$$I_{th}(R_1 = 0.3) = 0.32 \text{ A}$$

Reflection at the Laser-Waveguide Interface



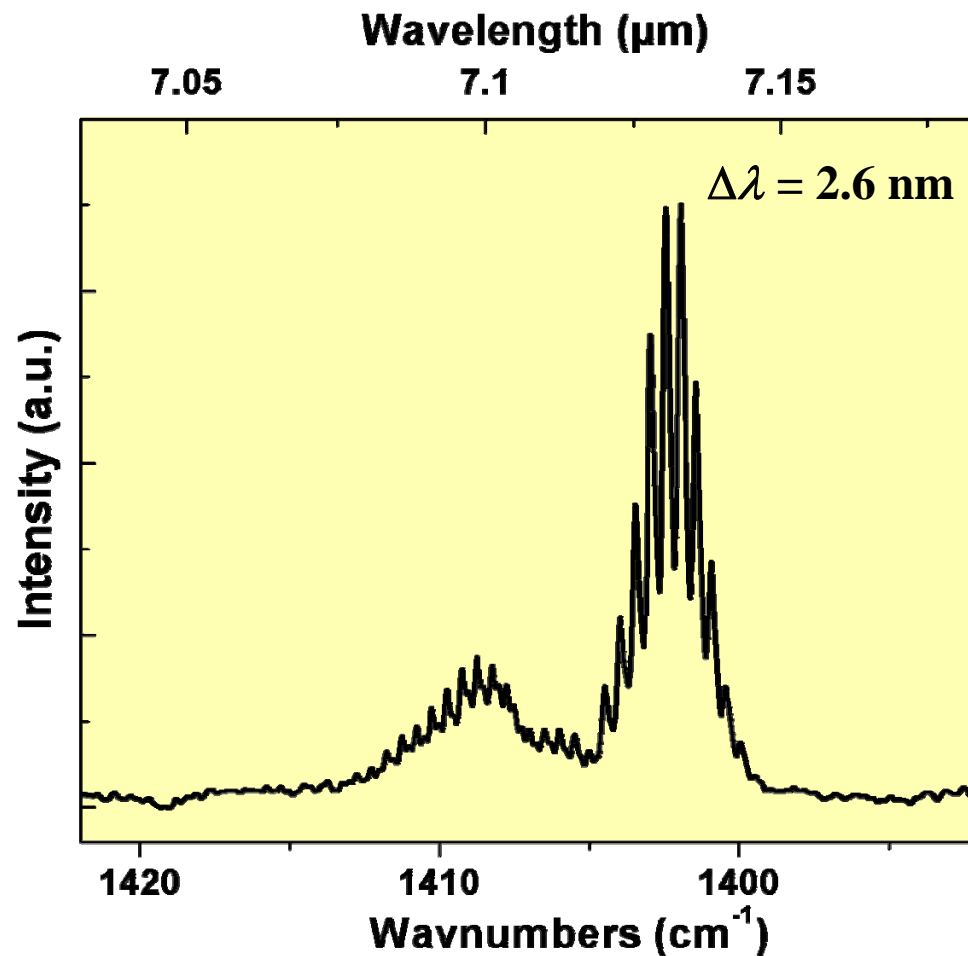
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Results: L-I



25% increase in J_{th}
 $R_1 \approx 0.03$

Results: Spectra



$$\Delta\lambda = \frac{\lambda^2}{2n_{\text{eff}}L}$$

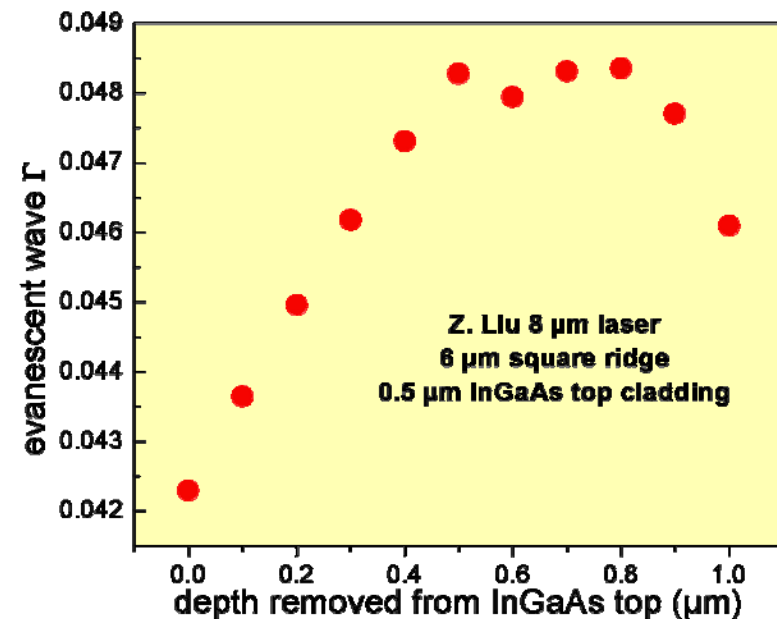
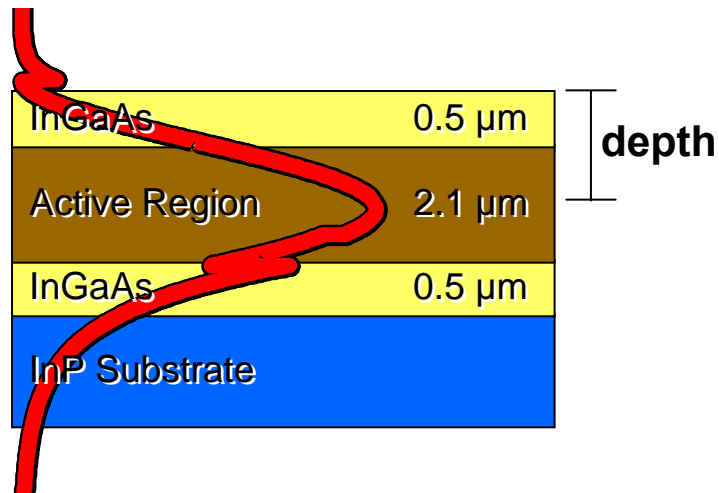
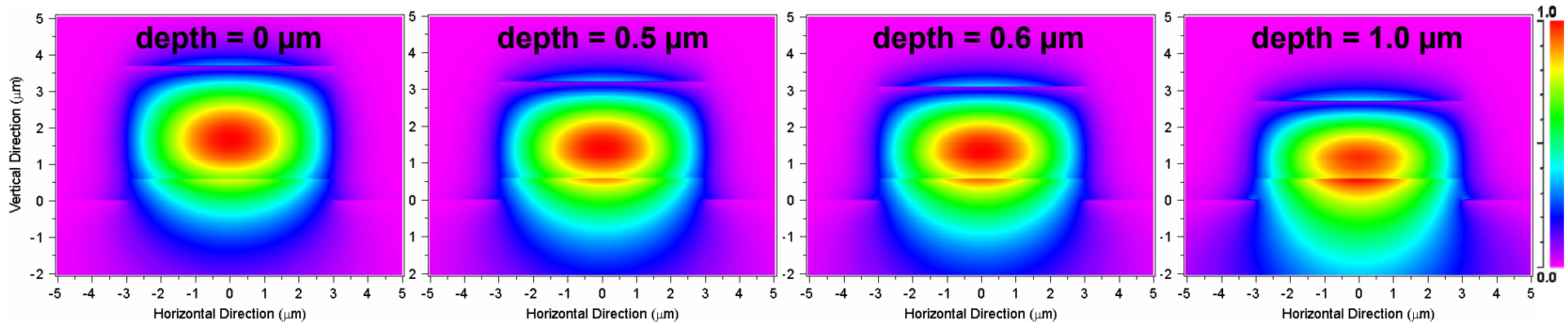
$$\lambda = 7.1 \mu\text{m}$$

$$n_{\text{eff}} = 3.2$$

$$L = 3 \text{ mm}$$

$$\Delta\lambda = 2.6 \text{ nm}$$

Mode Optimization



Summary



- Motivation: on-chip sensing capabilities for liquid-based molecular detection
- Demonstration of a monolithic QC integration method
- Acknowledgements
 - + DARPA L-PAS
 - + PRISM
 - + NSF Graduate Research Fellowship Program

